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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shyue-Ming JANG et al. Confirmation No: 1807
Appl. No. : 10/660,715
Filed : September 12, 2003
Title : APPARATUS AND PROCESS FOR VACUUM
SUBLIMATION

TC/A.U. : 4116
Examiner : B.M. Martinez

Docket No.: : JANG3005/REF
Customer No: : 23364

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Official Action of November 29, 2007, in connection with the above identified application. The period for response to this Official Action is set to expire on February 29, 2008. This response is timely filed.

Please amend the above-identified application as follows:

Amendments to the specification begin on page 2 of this paper.

Amendments to the claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 9 of this paper.